

FORM PTO-1449	Docket Number (Optional) 81870.0027	Application Number 10/758,692
INFORMATION DISCLOSURE CITATION IN AN APPLICATION	Applicant SHODA, et al.	
(Use several sheets if necessary)	Filing Date January 15, 2004	Group Art Unit 2872

JUN 22 2004

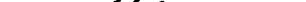
U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
PMC	03/093896	11/13/03	WO	—	—	X	
PMC	2002-321947	11/08/02	JAPAN	—	—	Abstract	
PMC	2000-056265	02/25/00	JAPAN	—	—	Abstract	
PMC	08-146351	06/07/96	JAPAN	—	—	Abstract	
—							

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

MC HAIMA, et al., "Surface Preparation and Phenomenological Aspects of Direct Bonding" Philips Journal of Research, Elsevier, Amsterdam, NL, vol. 49, no. 1, 1995, pages 23-46

EXAMINER		DATE CONSIDERED	6/16/2005
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.